

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Robert David Allen et al.

Examiner: John S.Y. Chu

Serial No.: 10/729,452

Group Art Unit: 1795

Filing Date: December 4, 2003

Confirmation No: 2060

Title: METHOD FOR PATTERNING A LOW ACTIVATION ENERGY PHOTORESIST

AMENDMENT UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed from the PTO on April 16, 2009. Please amend the application as indicated herein.

The *Listing of the Claims* begins on page 2 of this document. Amendments to the claims are reflected therein. With this amendment, claim 24 has been amended.

Remarks begin on page 11 of this document.